

2814



**TRANSMITTAL LETTER**  
**(General - Patent Pending)**

Docket No.  
11675.107

Re Application Of: **Kao et al.**

Serial No.  
08/720,693

Filing Date  
October 2, 1996

Examiner  
George Fourson

Group Art Unit  
2814

Title: **OXIDATION OF ION IMPLANTED SEMICONDUCTORS**

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is:

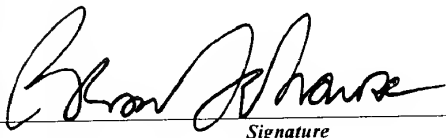
**Amendment Transmittal Letter; Amendment B (22 pgs); Copies of Two (2) Japanese documents; Postcard**

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in the above identified application.

- ☒ No additional fee is required.
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**22901**

PATENT TRADEMARK OFFICE

Dated: July <sup>5<sup>th</sup></sup>, 2000

I certify that this document and fee is being deposited on July 5, 2000 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

  
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